CLAIMS:

What is claimed is:

- 1 1. An integrated pixel sensor structure comprising:
- 2 a light sensitive diode including a transparent conductor;
- 3 and,
- a protective layer placed above the transparent conductor,
- 5 the protective layer including a set of diffraction grating
- 6 elements for producing complementary colors.
 - 2. The structure of claim 1, where the protective layer includes anti-reflection properties.
 - 3. The structure of claim 1, where the protective layer is a material suitable for fabrication processes that are compatible with the hight sensitive diode.
 - 4. The structure of claim 1, where the set of diffraction grating elements include a set of four step echelon grating
- 3 elements.

1 5. A system comprising:

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- 2 an integrated pixel sensor structure having:
- a light sensitive diode including a transparent conductor; and,
- a protective layer placed above the transparent

 conductor, the protective layer including a set of

 diffraction grating elements for producing complementary

 colors; and,
 - a post capture signal processing unit coupled to the integrated pixel sensor.
 - 6. The system of claim 5, where the protective layer includes anti-reflection properties.
 - 7. The system of claim 5, where the protective layer is a material suitable for fabrication processes that are compatible with the hight sensitive diode.
 - 1 8. The system of claim 5, where the set of diffraction grating
 - 2 elements include a set of four step echelon grating elements.

- 1 9. An apparatus comprising:
- 2 a light sensitive means;
- 3 a transparent conductor means displaced above the light
- 4 sensitive means; and,

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- 5 a protective layer means placed above the transparent
- 6 conductor means, the protective layer means including a set of
- 7 diffraction grating means for producing complementary colors.
 - 10. The apparatus of claim 9, where the protective layer means includes anti-reflection properties.
 - The apparatus of claim 9, where the protective layer means is a material suitable for fabrication processes that are compatible with the light sensitive means.
 - 12. The apparatus of claim 9, where the set of diffraction grating means include a set of four step echelon grating elements.

- 1 13. A method comprising:
- 2 providing a light sensitive element;
- 3 placing a transparent conductor above the light sensitive
- 4 element; and,

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- 5 placing a protective layer above the transparent conductor,
- 6 the protective layer including a set of diffraction grating
- 7 elements for producing complementary colors.
 - 14. The method of claim 13, where placing the protective layer includes placing a material with anti-reflection properties above the transparent conductor.
 - 15. The method of claim 13, where placing the protective layer includes placing a material suitable for fabrication processes that are compatible with the light sensitive element.
 - 16. The method of claim 13, where the set of diffraction grating elements include a set of four step echelon grating
- 3 elements.

